IFW



Atty Dkt.: 8733.213.00-US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. of:

Jin JANG et al.

Confirmation No.:

7572

Appln. No.:

09/497,508

Group Art Unit:

2814

Filed:

February 4, 2000

Examiner:

LOUIE, W.S.

For:

POLYCRYSTALLINE SILICON

FILM CONTAIN Ni

Customer No.:

30827

Mail Stop Amendment

Commissioner of Patents P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Sir:

In response to the Office Action dated September 12, 2007, please amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendment to the Claims is reflected in the listing of claims which begins on page 2 of this paper; and

Remarks begin on page 4 of this paper.